

United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE
United States Patent and Trademark Office
Address: COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, Virginia 22313-1450
www.uspto.gov

APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/639,925	08/12/2003	Dirk Preiksas	920602-94605	6666
23644	7590 10/12/2005	EXAMINER		INER
	& THORNBURG	LE, TOAN M		
P.O. BOX 2 CHICAGO,	IL 60690-2786	ART UNIT	PAPER NUMBER	
		2863		
			DATE MAILED: 10/12/2006	ς .

Please find below and/or attached an Office communication concerning this application or proceeding.

		Appli	cation No.	Applicant(s)				
Office Action Summan		10/63	39,925	PREIKSAS ET AL	. (AM)			
	Office Action Summary	Exam	iner	Art Unit				
		Toan		2863				
Period fo	The MAILING DATE of this commu or Reply	nication appears or	i the cover sheet w	vith the correspondence ad	dress			
THE - Exte after - If the - If NC - Failt Any	ORTENED STATUTORY PERIOD IN MAILING DATE OF THIS COMMUN nsions of time may be available under the provision SIX (6) MONTHS from the mailing date of this comperiod for reply specified above is less than thirty to period for reply is specified above, the maximum sure to reply within the set or extended period for reply received by the Office later than three months ed patent term adjustment. See 37 CFR 1.704(b).	NICATION. us of 37 CFR 1.136(a). In rumication. (30) days, a reply within the statutory period will apply a by will, by statute, cause the	no event, however, may a e statutory minimum of th and will expire SIX (6) MO e application to become A	reply be timely filed irty (30) days will be considered timel NTHS from the mailing date of this co NBANDONED (35 U.S.C. § 133).	y. ommunication.			
Status								
1)⊠	Responsive to communication(s) file	led on <u>27 July 200</u> 5	<u>5</u> .					
2a)⊠	This action is FINAL. 2b) This action is non-final.							
3)□	Since this application is in condition for allowance except for formal matters, prosecution as to the ments is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.							
Disposit	ion of Claims							
5)⊠	Claim(s) <u>1-21</u> is/are pending in the 4a) Of the above claim(s) is/ Claim(s) <u>19-21</u> is/are allowed. Claim(s) <u>1,6-13 and 18</u> is/are reject	are withdrawn from	n consideration.					
· · · —	Claim(s) <u>2-5 and 14-17</u> is/are object							
8)□	Claim(s) are subject to restr	iction and/or election	on requirement.					
Applicat	ion Papers			,				
9)[The specification is objected to by the	he Examiner.						
10)⊠	The drawing(s) filed on 27 July 200	- .		•				
	Applicant may not request that any obj	-	•	` *				
11)	Replacement drawing sheet(s) including The oath or declaration is objected.	•	•	• • •	` '			
Priority (under 35 U.S.C. § 119							
a)	Acknowledgment is made of a claim All b) Some * c) None of: 1. Certified copies of the priority 2. Certified copies of the priority 3. Copies of the certified copies application from the Internations See the attached detailed Office actions	y documents have y documents have s of the priority doc onal Bureau (PCT	been received. been received in a uments have been Rule 17.2(a)).	Application No n received in this National	Stage			
2) Notice 3) Information Paper	t(s) te of References Cited (PTO-892) te of Draftsperson's Patent Drawing Review (mation Disclosure Statement(s) (PTO-1449 or No(s)/Mail Date 7/27/05		Paper No	Summary (PTO-413) (s)/Mail Date Informal Patent Application (PTC	D-152)			

Application/Control Number: 10/639,925

Art Unit: 2863

DETAILED ACTION

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claims 1, 6-13, and 18 are rejected under 35 U.S.C. 102(b) as being anticipated by "Development and Application of a Computer Control System for an Analytical Electron Microscope", Schneider et al. (referred hereafter Schneider et al.).

Referring to claim 1, Schneider et al. disclose an instrument (figure 2) having a user controllable operating parameter (page 888, 2nd col., 1st and 2nd paragraphs) and at least one further operating parameter having a required value at least partially dependent on that of said user controllable parameter (page 889, 2nd col., 2nd paragraph), the instrument also having a memory for storing a number of possible values of the further operating parameter, each said value corresponding to a respective possible value of the user controllable parameter (page 889, 2nd col., 2nd paragraph; page 887, 2nd col., last paragraph to page 888, 1st col., 1st paragraph), a selector for selecting one of said stored possible values for the further parameter and controlling the instrument accordingly (page 889, 2nd col., 2nd paragraph; page 887, 2nd col., last paragraph to page 888, 1st col., 1st paragraph), a tuner for enabling a user to alter the selected value (page 889, 2nd col., 1st paragraph; page 887, 2nd col., 1st paragraph), and updating apparatus for updating the memory accordingly, so that the adjusted value of the further operating parameter is selected from the memory if the same value of user controllable parameter

is then chosen again (page 890, 1st col., 3rd paragraph; page 887, 2nd col., last paragraph to page 888, 1st col., 1st paragraph; figure 2).

As to claim 6, Schneider et al. disclose an instrument (figure 2), in which the further operating parameter is one of a plurality of such parameters, values for all of which are stored in the memory means (page 887, 1st col., 1st paragraph).

Referring to claim 7, Schneider et al. disclose an instrument (figure 2), in which the instrument is a charged particle beam instrument having beam generating means for generating charged particles and for subjecting said particles to an accelerating voltage to create a beam, and an alignment element for controlling the alignment of the beam, wherein said accelerating voltage constitutes the user controllable parameter and the further operating parameter comprises a setting for the alignment element (page 889, 2nd col., 1st and 2nd paragraphs).

As to claim 8, Schneider et al. disclose an instrument (figure 2), in which the alignment element is a magnetic coil, and the associated further parameter is the value or relative value of current passed through the coil (page 887, 1st col., 1st paragraph; page 889, 2nd col., 1st and 2nd paragraphs).

Referring to claim 9, Schneider et al. disclose an instrument (figure 2), in which the alignment element is an electrode the value of the associated parameter being the voltage applied to the electrode (page 889, 2nd col., 1st and 2nd paragraphs).

As to claim 10, Schneider et al. disclose an instrument (figure 2), when appended to claim 6 in which the instrument has a plurality of different alignment coils, and the further operating parameters comprise the currents in the coils or the relative current magnitudes in the coils (page 889, 2nd col., 1st and 2nd paragraphs).

Application/Control Number: 10/639,925

Art Unit: 2863

Referring to claim 11, Schneider et al. disclose an instrument (figure 2), in which the charged particle beam instrument is a scanning electron microscope, the beam generating means, comprising an electron gun having a cathode and an extraction electrode to which said accelerating voltage is applied, the alignment coils acting as gun alignment coils for controlling the alignment of the beam onto an electron optical axis of the microscope (page 888, 2nd col., 2nd and 3rd paragraphs; page 889, 2nd col., 1st and 2nd paragraphs; figure 2).

As to claim 12, Schneider et al. disclose an instrument (figure 2), in which the electron microscope includes a plurality of apertures in the path of a beam to be generated by the beam generating means, wherein the alignment coils are operable to direct the beam through any selected one of the apertures (page 889, 2nd col., 1st and 2nd paragraphs).

Referring to claim 13, Schneider et al. disclose an instrument (figure 2), in which the magnitude of the accelerating voltage comprises one of a plurality of user controllable parameters, another such parameter being constituted by the identity of the aperture through which the beam is to pass (page 889, 2nd col., 1st and 2nd paragraphs).

As to claim 18, Schneider et al. disclose a scanning charged particle beam instrument (figure 2) having a gun for generating the beam of charged particles, a plurality of apertures through any selected one of which the beam may pass, an accelerating electrode to which a voltage is applied to accelerate the particles away from the gun, and at least one alignment element for directing the beam through the selected aperture, wherein the further parameter values which are stored in a memory comprise values for the settings of the alignment element dependent on the voltage applied to the accelerating electrode and the choice of aperture (page

Art Unit: 2863

889, 2nd col., 2nd paragraph; page 890, 1st col., 1st paragraph; page 887, 2nd col., last paragraph to page 888, 1st col., 1st paragraph).

Allowable Subject Matter

Claims 2-5 and 14-17 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

The reason for allowance of the claims 2-5 and 14-17 is the inclusion of selecting an intermediate value of the user controllable operating parameter corresponding entries in the memory for interpolating and adjusting and updating the further parameter value, which is then stored using an index being part of a look-up table in operating the instrument, such as a microscope.

Claims 19-21 are allowable for the same feature described above.

Response to Arguments

Applicant's arguments filed 7/27/05 have been fully considered but they are not persuasive.

Referring to claim 1, Applicant argues that "The microprocessor may have a memory, as suggested by the Examiner, but there is no indication that the memory stores a number of possible values of any operating parameter, each selected in response to the selection of a value for a different, user controllable operating parameter. Claim 1 also includes the feature that the value of a further parameter, which has been selected in response to the selection by user of a value for another parameter, may be tuned by the user and the adjusted value of the tune parameter can then be stored in the memory so that the adjusted value of that parameter (i.e. the

Art Unit: 2863

one not directly chosen by the user) is selected from the memory if the same value of the user selectable parameter is chosen again at a later time."

Schneider et al. disclose 'Besides these technical and operational advantages, electron beam damage to the specimen can be minimized by digital image acquisition; once the image of the region of interest is stored, further data such as line profile measurement may be extracted at a later time, if needed.' On page 887, 2nd col., last paragraph to page 888, 1st col., 1st paragraph.

Thus, Schneider et al. teach those features above.

Conclusion

THIS ACTION IS MADE FINAL.

Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Toan M. Le whose telephone number is (571) 272-2276. The examiner can normally be reached on Monday through Friday from 9:00 A.M. to 5:30 P.M..

Application/Control Number: 10/639,925

Art Unit: 2863

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, John Barlow can be reached on (571) 272-2269. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Toan Le

October 6, 2005

BRYAN BUI PRIMARY EXAMINER

Page 7